## JAP15 Rec'd PCT/PTO 06 JAN 2006

DOCKET NO.: 283410US0PCT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jean BRUN, et al. SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HEREWITH

INTERNATIONAL APPLICATION NO.: PCT/FR04/50335

INTERNATIONAL FILING DATE: July 15, 2004

FOR: METHOD FOR PRODUCING AN ANISOTROPIC CONDUCTIVE FILM ON A

**SUBSTRATE** 

## REQUEST FOR PRIORITY UNDER 35 U.S.C. 119 AND THE INTERNATIONAL CONVENTION

Commissioner for Patents Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicant claims as priority:

**COUNTRY** 

**APPLICATION NO** 

DAY/MONTH/YEAR

France 03 50352

18 July 2003

Certified copies of the corresponding Convention application(s) were submitted to the International Bureau in PCT Application No. PCT/FR04/50335.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

Customer Number

22850

(703) 413-3000 Fax No. (703) 413-2220 (OSMMN 08/03) Norman F. Oblon Attorney of Record Registration No. 24,618

Surinder Sachar

Registration No. 34,423